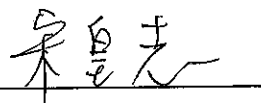


103 學年度商學院 英文授課課程大綱

<p>課程名稱 Course Title <input type="checkbox"/>模組 <input checked="" type="checkbox"/>個別</p>	<p>(中文) 美國專利實務 (英文) US Patent Practice</p>
<p>課程目標 Course Objectives</p>	<p>This course aims at helping students understand the US Patent Law and Patent Practice, especially in the newest patent act amendment--America Invents Act (AIA) which was enacted on Sept. 16, 2011 and became effective in 2013.</p>
<p>課程大綱 Course Description</p>	<p>This Course covers the following topics: 1. Introduction to the US Patent Law and the America Invents Act; 2. Patent Search, Patent Analysis, and Patent Map; 3. Reading and drafting of a patent specification and claims; 4. Global patent applications; 5. Patent Examination: including the legal requirements of patent eligibility, allowable subject matters, utility, novelty, and non-obviousness; 6. Patent Infringement Analysis, including the doctrines of all-element rule, literal infringement, infringement under doctrine of equivalence, estoppel, dedication to the public, and practicing the prior art.</p>
<p>上課進度 Weekly Course Schedule</p>	<p>The Weekly Course Schedule from Weeks 1 to 18 is as the follows: Week 1: Introduction to the US Patent Law Week 2: Introduction to the America Invents Act Week 3: Patent Search and Patent Analysis Week 4: Patent Map Week 5: Reading and drafting of a patent specification and claims Week 6: Global patent applications Week 7: Patent Examination: the legal requirement of patent eligibility Week 8: Patent Examination: the legal requirement of allowable subject matters Week 9: Patent Examination: the legal requirement of utility Week 10: Patent Examination: the legal requirement of novelty</p>

	<p>Week 11: Patent Examination: the legal requirement of non-obviousness</p> <p>Week 12: Patent Infringement Analysis: the doctrines of all-element rule and literal infringement</p> <p>Week 13: Patent Infringement Analysis: infringement under doctrine of equivalence</p> <p>Week 14: Patent Infringement Analysis: the doctrine of estoppel</p> <p>Week 15: Patent Infringement Analysis: the doctrines of dedication to the public, and practicing the prior art</p> <p>Week 16: Real Practice and Discussion</p> <p>Week 17: Real Practice and Discussion</p> <p>Week 18: Real Practice and Discussion</p>
<p>教學方式 Instructional Method</p>	<p>The Instructional Methods of this course include: teacher's lectures and students' reading/discussing/presentation of important cases</p>
<p>課程要求 Course Requirements</p>	<p>This course would anticipate students to recognize the legal, technological, industrial and economic approaches of the US Patent Law and Practice.</p> <p>The Final Report of this course will request the students to conduct a complete patent infringement analysis regarding a synario provided by the instructor.</p>
<p>評量方式 Evaluation</p>	<p>Class Participation 20%</p> <p>Group Discussion and Case Presentation 40%</p> <p>Final Report 40%</p>
<p>教材及參考書目 Textbooks & Suggested Materials</p>	<p>1. JANICE M. MUELLER, PATENT LAW (Fourth Edition, 2013).</p> <p>2. DAVID PRESSMAN, PATENT IT YOURSELF – YOUR STEP-BY-STEP GUIDE TO FILING AT THE U.S. PATENT OFFICE (16th Edition, 2012).</p>
<p>課程相關 連結網址 Course Website</p>	

申請教師簽章：



開課單位主管簽章：

